

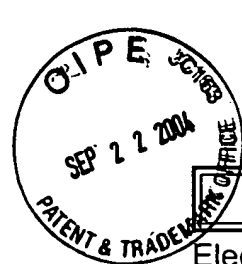
SP23



Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only


EFS ID: 68956
Application ID: 10622001
ELECTROCHEMICAL DEPOSITION
SYSTEM AND METHOD OF
ELECTROPLATING ON
SUBSTRATES
Title of Invention:
First Named Inventor: UZIEL LANDAU
Domestic/Foreign Application: Domestic Application
Filing Date: 2003-07-17
Effective Receipt Date: 2004-09-22
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 2266
Attorney Docket Number: AMAT2601R2
Total Fees Authorized: 180.0
Payment Category: Deposit Account
Deposit Account Number: 200782
Deposit Account Name: N. ALEXANDER NOLTE
Access Code: ****
RAM Payment Status: RAM success
RAM User ID: EFSPROD
RAM Accounting Date: 2004-09-22
RAM Sequence Number: 31

Digital Certificate Holder: cn=N. Alexander Nolte,ou=Registered Attorneys,ou=Patent and
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
Certificate Message Digest: 81b7d4046ac0875b1e45aa93cf60d33d735343c8

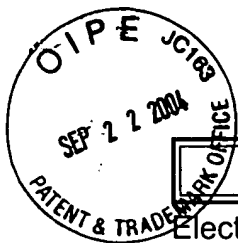


TRANSMITTAL

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention	ELECTROCHEMICAL DEPOSITION SYSTEM AND METHOD OF ELECTROPLATING ON SUBSTRATES							
Application Number: 10/622001 								
Date: 2003-07-17								
First Named Applicant: Mr. UZIEL LANDAU								
Confirmation Number: 2266								
Attorney Docket Number: AMAT2601R2								
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>								
<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Mr. N. ALEXANDER NOLTE Registered Number: 45689</td><td>/N. ALEXANDER NOLTE/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Mr. N. ALEXANDER NOLTE Registered Number: 45689	/N. ALEXANDER NOLTE/	Attorney
Submitted by:	Elec. Sign.	Sign. Capacity						
Mr. N. ALEXANDER NOLTE Registered Number: 45689	/N. ALEXANDER NOLTE/	Attorney						

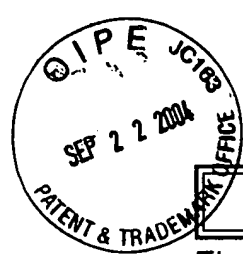
Documents being submitted	Files
us-ids	AMAT2601R2BTP-usidst.xml
	us-ids.dtd
	us-ids.xsl
us-fee-sheet	AMAT2601R2BTP-usfees.xml
	us-fee-sheet.xsl
	us-fee-sheet.dtd
Comments	

**FEE TRANSMITTAL**

Electronic Version v08

Stylesheet Version v08.0


Title of Invention	ELECTROCHEMICAL DEPOSITION SYSTEM AND METHOD OF ELECTROPLATING ON SUBSTRATES										
Application Number: 10/622001 											
Date: 2003-07-17											
First Named Applicant: Mr. UZIEL LANDAU											
Attorney Docket Number: AMAT2601R2											
Art Unit: 1741											
TOTAL FEE AUTHORIZED \$180											
Patent fees are subject to annual revisions on or about October 1st of each year.											
BASIC FILING FEE											
<table border="1"><thead><tr><th>Fee Description</th><th>Fee Code</th><th>Amount \$</th><th>Fee Paid \$</th></tr></thead><tbody><tr><td>Submission Of Information Disclosure Stmt Fee</td><td>1806</td><td>180</td><td>180</td></tr></tbody></table>				Fee Description	Fee Code	Amount \$	Fee Paid \$	Submission Of Information Disclosure Stmt Fee	1806	180	180
Fee Description	Fee Code	Amount \$	Fee Paid \$								
Submission Of Information Disclosure Stmt Fee	1806	180	180								
AUTHORIZED BILLING INFORMATION											
The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:											
Deposit account number: 200782											
Access Code *****											
Deposit name: MOSER PATTERSON SHERIDAN											
Deposit authorized name: N. ALEXANDER NOLTE											
Signature: /N. ALEXANDER NOLTE/											
Date (YYYYMMDD): 2004-09-22											



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	ELECTROCHEMICAL DEPOSITION SYSTEM AND METHOD OF ELECTROPLATING ON SUBSTRATES																				
<p>Application Number: 10/622001 </p> <p>Confirmation Number: 2266</p> <p>First Named Applicant: UZIEL LANDAU</p> <p>Attorney Docket Number: AMAT2601R2</p> <p>Art Unit: 1741</p> <p>Search string: (4120771).pn.</p> <p>US Patent Documents</p> <p>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td></td><td>1</td><td>4120771</td><td>1978-10-17</td><td>DEWALLENS</td><td></td><td></td><td></td></tr></tbody></table> <p>Signature</p> <table border="1"><thead><tr><th>Examiner Name</th><th>Date</th></tr></thead><tbody><tr><td></td><td></td></tr></tbody></table>		init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass		1	4120771	1978-10-17	DEWALLENS				Examiner Name	Date		
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass														
	1	4120771	1978-10-17	DEWALLENS																	
Examiner Name	Date																				